

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Halahan, Patrick B.; Siniaguine, Oleg
Assignee: Tru-Si Technologies, Inc.
Title: Semiconductor Structures Having Multiple Conductive Layers In An Opening, And Methods For Fabricating Same
Serial No.: Not yet known Filing Date:
Examiner: Not yet known Group Art Unit: Not yet known
Docket No.: M-9999-1D US

San Jose, California
August 28, 2001

Box Patent Application
COMMISSIONER FOR PATENTS
Washington, D. C. 20231

PRELIMINARY AMENDMENT

Dear Sir:

Please amend the above-identified application as follows.

IN THE SPECIFICATION

On page 1, before line 6, please insert the following paragraphs:

-- CROSS-REFERENCE TO RELATED APPLICATIONS

The present application is a division of U.S. patent application no. 09/792,311 filed February 22, 2001, incorporated herein by reference. --

IN THE CLAIMS

Please cancel Claims 13-19 and 23-29 without prejudice.

LAW OFFICES OF
SKJERVEN MORRILL
MACPHERSON LLP
25 METRO DRIVE
SUITE 700
SAN JOSE, CA 95110
(408) 453-9200
FAX (408) 453-7979

REMARKS

Claims 1-12 and 20-22 remain in the application.

EXPRESS MAIL LABEL NO:

EL 884 815 018 US

Respectfully submitted,



Michael Shenker
Attorney for Applicant(s)
Reg. No. 34,250

795237 v1

LAW OFFICES OF
SKJERVEN MORRILL
MACPHERSON LLP

25 METRO DRIVE
SUITE 700
SAN JOSE, CA 95110
(408) 453-9200
FAX (408) 453-7979

795237 v1